Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application.

Listing of Claims:

Claims 1-46 (Canceled)

Claim 47 (Previously presented): The semiconductor die of claim 67, wherein said tip structure is integrally formed with said one of the interconnection elements.

Claim 48 (Previously presented): The semiconductor die of claim 67, wherein said one of the interconnection elements comprises a buckling beam interconnection element.

Claim 49 (Previously presented): The semiconductor die of claim 67, wherein said one of the interconnection elements is resilient.

Claims 50-52 (Canceled)

Claim 53 (Previously presented): The semiconductor die of claim 67, wherein said tip structure comprises at least one of palladium, cobalt, rhodium, tungsten, or diamond.

Claim 54 (Previously presented): The semiconductor die of claim 67, wherein said tip structure comprises a material comprising a spring alloy.

Claim 55 (Previously presented): The semiconductor die of claim 67, wherein said tip structure is secured to said one of the interconnection elements by one of braze or solder.

Claims 56-59 (Canceled)

Claim 60 (Currently amended): A semiconductor die tested by making temporary electrical

connections between interconnection elements of a contactor device and terminals of the die, the

method of making the temporary electrical connections comprising:

forcing into contact ones of the moving at least one of the die or the contactor device

such that terminals [[and]] of the die are pressed against blades of ones of the interconnection

elements of the contactor device, each blade comprising a cutting edge along a length of the

blade,

the pressing of the terminals against the blades causing bodies of the interconnection

elements to deflect away from the terminals, which causes the blades deflecting to wipe across

the terminals in a motion that is within plus or minus forty-five degrees of an axis aligned with

the length of the blade, the cutting edge of each blade slicing into a surface of [[one]] each of the

terminals so that a slice mark is created on the one each of the terminals.

Claim 61 (Currently amended): The semiconductor die of claim 60, wherein the deflecting

motion of the blades across the terminals is within plus or minus thirty degrees of the axis.

Claim 62 (Currently amended): The semiconductor die of claim 60, wherein the deflecting

motion of the blades across the terminals is approximately parallel to the axis.

Claim 63 (Previously presented): The semiconductor die of claim 60, wherein the blades slice

through oxide layers formed on the terminals.

Claims 64-66 (Canceled)

Claim 67 (Previously presented): The semiconductor die of claim 60, wherein each of the blades

composes a tip structure disposed on one of the interconnection elements.

Claims 68 and 69 (Canceled)

Claim 70 (Previously presented): The semiconductor die of claim 60, wherein each of the blades

comprises tapered portions that form the cutting edge along the length of the blade.

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Claim 71 (Previously presented): The semiconductor die of claim 60, wherein each of the blades

comprises a base portion that is larger than the cutting edge of the blade, the blade further

comprising tapered sidewalls that taper from the base portion to the cutting edge.

Claim 72 (Previously presented): The semiconductor die of claim 60, wherein the axis is

coincident with the length of the blade.

Claim 73 (New): The semiconductor die of claim 60, wherein the slice mark created on each of

the terminals corresponds to a portion of a shape of the corresponding blade that wipes across the

terminal.

Claim 74 (New): The semiconductor die of claim 73, wherein the portion of the shape of the

corresponding blade includes the cutting edge, which is formed by an intersection of inwardly

sloping side walls of the corresponding blade.

Claim 75 (New): The semiconductor die of claim 73, wherein each blade comprises a first side

wall and a second side wall, and wherein the first side wall slopes toward the second side wall

and the second side wall slopes toward the first side wall such that the first side wall and the

second side wall intersect to form the cutting edge of the blade, the portion of the shape of the

corresponding blade comprising a portion of the first side wall, a portion of the second side wall,

and at least a portion of the cutting edge.

Claim 76 (New): The semiconductor die of claim 73, wherein the shape of the corresponding

blade comprises a triangular cross-sectional shape, a tip of the cross-sectional shape

corresponding to the cutting edge, wherein the portion of the shape includes the tip of the

triangular cross-sectional shape.

Claim 77 (New): The semiconductor die of claim 60, wherein the blades comprise palladium,

rhodium, tungsten, or diamond.

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Claim 78 (New): The semiconductor die of claim 60, wherein the blades comprise a first material and the terminals comprise a second material, and the first material is harder than the second material.